

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: KIKUO MAEDA ET AL. )  
Serial No.: 10/807,774 ) Group Art Unit: 1792  
Filed: March 23, 2004 ) Examiner: Crowell, Anna M  
For: THIN FILM FORMING APPARATUS ) Confirmation No. 4282  
AND THIN FILM FORMING METHOD )

Customer No.: 23413

**RESPONSE TO RESTRICTION REQUIREMENT**

Via EFS  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Restriction Requirement mailed February 6, 2008, Applicant submits the following response.